L	Hits	Search Text	1 55	1
Number	nits	Search Text	DB	Time stamp
-	50909	substrate and (crystalline or (single adj	USPAT	2001/10/00
		crystalline) or single-crystalline or	USPAT	2001/10/29
		monocrystalline or mono-crystalline)		09:14
l <u>-</u>	12606	(substrate and (crystalline or (single	USPAT	2001 /10 /00
	12000	adj crystalline) or single-crystalline or	USPAT	2001/10/29
i		monocrystalline or mono-crystalline) )		09:14
		and (mask or optical adj mask)		
_	1784	((substrate and (crystalline or (single	USPAT	2001 /10 /20
	1,01	adj crystalline) or single-crystalline or	USPAT	2001/10/29
	İ	monocrystalline or mono-crystalline of		09:16
		and (mask or optical adj mask)) and		İ
	]	irradiat\$4 and (laser or lasers)	'	
_	1331	(((substrate and (crystalline or (single	USPAT	2001/10/29
		adj crystalline) or single-crystalline or	OSPAI	09:16
		monocrystalline or mono-crystalline) )		05.10
		and (mask or optical adj mask)) and		
		irradiat\$4 and (laser or lasers)) and		
		(insulati\$4 or dielectric)		i
-	523	((((substrate and (crystalline or (single	USPAT	2001/10/29
		adj crystalline) or single-crystalline or		09:24
		<pre>monocrystalline or mono-crystalline) )</pre>		
		and (mask or optical adj mask)) and		
		irradiat\$4 and (laser or lasers)) and		
		(insulati\$4 or dielectric)) and		
		(alignment or (alignment adj mark))		
-	381	((((substrate and (crystalline or	USPAT	2001/10/29
		(single adj crystalline) or		11:41
		single-crystalline or monocrystalline or		
		mono-crystalline) ) and (mask or optical		
		adj mask)) and irradiat\$4 and (laser or		
ļ		lasers)) and (insulati\$4 or dielectric))		
		and (alignment or (alignment adj mark)))		
_	_	and amorphous and crystalline	IICDAM.	2001/10/20
_	1	("5821562").PN.	USPAT	2001/10/29
_	1	(("5821562").PN.) and (mask same laser)	USPAT	11:41   2001/10/29
		(( JULIJUZ ).FN.) and (mask same laser)	OSPAI	11:42
_	1	(("5821562").PN.) and mask and laser	USPAT	2001/10/29
	1	( Joziotz ). FN.) and mask and lasel	OJFAI	12:50
·				12.30

			_	
L Number	Hits	Search Text	DB	Time stamp
-	44910	semiconductor adj substrate	USPAT	2001/10/19
-	85		USPAT	11:50 2001/10/18
-	37	, ( = = = = = = = = = aa, babbcrace, and	USPAT	13:48 2001/10/18
		(optical adj mask)) and (insualt\$3 or dielectric)		13:49
-	11	(optical adj mask)) and (insualt\$3 or	USPAT	2001/10/18 14:05
_	224	dielectric)) and (laser or lasers) ("438/697").CCLS.	USPAT	2001/10/18
-	26	(("438/697").CCLS.) and (laser or lasers)	USPAT	14:08 2001/10/18 14:12
_	1	((("438/697").CCLS.) and (laser or lasers)) and (optical adj mask)	USPAT	2001/10/18 14:15
-	1		USPAT	2001/10/18 14:16
-	1426	laser adj annealing	USPAT	2001/10/18 14:16
_	7	mask)	USPAT	2001/10/18 14:16
-	7	mask)) and (insulat\$3 or dielectric)	USPAT	2001/10/18 14:17
_	1486	(laser adj annealing) or (laser adj crystalliz\$4)	USPAT	2001/10/19
-	476	crystalliz\$4)) and alignment	USPAT	2001/10/19
_	419	(((laser adj annealing) or (laser adj crystalliz\$4)) and alignment) and (insulating or dielectric)	USPAT	2001/10/19 10:29
_	13	((((laser adj annealing) or (laser adj crystalliz\$4)) and alignment) and (insulating or dielectric)) and amorphous	USPAT	2001/10/19 10:30
		and (single adj crystalline) and (monocrystalline)		
-	1	("5643826").PN.	USPAT	2001/10/19 11:50
_	1	(("5643826").PN.) and laser	USPAT	2001/10/19 12:01
-	1	("5620910").PN.	USPAT	2001/10/19 12:01
-	1	(("5620910").PN.) and laser	USPAT	2001/10/19 12:01
_	1	((("5620910").PN.) and laser) and alignment	USPAT	2001/10/19 12:09
_	473	Crystal\$ and laser and (alignment adj mark)	USPAT	2001/10/19 12:14
_	23	(Crystal\$ and laser and (alignment adj mark)) and (amorphous adj silicon) and	USPAT	2001/10/19 12:15
_	0	(crystalline adj silicon) ((Crystal\$ and laser and (alignment adj mark)) and (amorphous adj silicon) and	USPAT	2001/10/19 12:15
_	0	(crystalline adj silicon)) and ((laser adj anneal) same mask) ((Crystal\$ and laser and (alignment adj	USPAT	2001/10/19
		mark)) and (amorphous adj silicon) and (crystalline adj silicon)) and ((laser adj anneal) and mask)		12:15
-	0	<pre>((Crystal\$ and laser and (alignment adj mark)) and (amorphous adj silicon) and (crystalline adj silicon)) and ((laser</pre>	USPAT	2001/10/19 12:16
-		adj anneal) and (ARC or mask or resist)) ((Crystal\$ and laser and (alignment adj mark)) and (amorphous adj silicon) and	USPAT	2001/10/19 12:16
		(crystalline adj silicon)) and (laser adj anneal)		

-	5	((Crystal\$ and laser and (alignment adj mark)) and (amorphous adj silicon) and	USPAT	2001/10/24
		(crystalline adj silicon)) and (laser adj anneal\$)		11:02
-	5	((Crystal\$ and laser and (alignment adj mark)) and (amorphous adj silicon) and (crystalline adj silicon)) and (laser adj	USPAT; US-PGPUB; EPO; JPO;	2001/10/24 11:03
	_	anneal\$)	DERWENT; IBM TDB	
<del>-</del> :	5	((Crystal\$ and laser and (alignment adj mark)) and (amorphous adj silicon) and (crystalline adj silicon)) and (laser adj anneal\$)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM TDB	2001/10/24
-	4527	(thin adj film adj resistor\$2)	USPAT; US-PGPUB; EPO; JPO; DERWENT;	2001/10/24 11:08
-	94	((thin adj film adj resistor\$2) ) and amorphous and ((single adj crystalline) or monocrystalline or crystalline)	IBM TDB USPAT; US-PGPUB; EPO; JPO; DERWENT;	2001/10/24 11:38
-	16	(("5569610") or ("5543352") or ("0553416") or ("5531182") or ("5529937") or ("5508533") or ("5501989") or ("5488000") or ("5481121") or ("54037722") or ("5289030") or ("5278093") or ("5278093") or ("4309223") or ("4068020") or ("43783049")).PN.	IBM TDB	2001/10/24 11:40
-	466		USPAT	2001/10/25
-	305	(("257/350").CCLS.) and ((laser adj anneal) or crystal\$ or irradiat\$4)	USPAT	2001/10/25 15:49
-	273	(("257/350").CCLS.) and (amorphous or (single-crystalline) or monocrystalline or (single adj crystalline) or	USPAT	2001/10/25 15:52
-	104	crystalline) ((("257/350").CCLS.) and ((laser adj anneal) or crystal\$ or irradiat\$4)) and amorphous and (single-crystalline or monocrystalline or crystalline or (single adj crystalline))	USPAT	2001/10/25 16:11